



37230

PATENT
ty. Dkt. No. AMAT/5297/DSM/LOW K/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#10 / Amended
B

In re Application of:
Rivoire, et al.

Serial No.: 09/844,991

Confirmation No.: 1361

Filed: April 27, 2001

For: Method for Planarizing
Organosilicate Layers

Group Art Unit: 3723

Examiner: Robert Rose

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AUG 07 2003

TECHNOLOGY CENTER R3700

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on July 30, 2003, with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
July 30, 2003 Date	<i>Kurt R. J. J.</i> Signature

RESPONSE TO OFFICE ACTION DATED JUNE 18, 2003

In response to the Office Action dated June 18, 2003, having a shortened statutory period for response set to expire on September 18, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no fee is due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5297/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. **Remarks/Arguments** begin on page 7 of this paper.